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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention	SELECTIVE SILICON-ON-INSULATOR ISOLATION STRUCTURE AND METHOD						
Application Number:		10/604102					
Confirmation Number:							
First Named Applicant:		An Steegan					
Attorney Docket Number:		FIS920030051					
Search string:		(6429091 or 5153813 or 4849376 or 20020185469).pn.					
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
72	1	6429091	2002-08-06	Chen et al.	438	423	
74	2	5153813	1992-10-06	Oehrlein et al.	361	313	
74	3	4849376	1989-07-18	Balzan et al.	438	582	
US Published Applications							
Note: Applicant is not required to submit a paper copy of cited US Published Applications							
init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
92	1	20020185469	2002-12-12	Podlesnik et al.	216	41	
Signature							
Examiner Name				Date			
92 Robert				7/30/04			